

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :

Masamichi NAKASHIBA et al. : Docket No. 2000-0722

Serial No. 09/589,388

Filed June 8, 2000

APPARATUS FOR AND METHOD FOR
POLISHING WORKPIECE



THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

AMENDMENT IN REISSUE

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

Prior to initial examination of the above-referenced reissue application, kindly amend the application as follows:

IN THE CLAIMS:

Please add the following new claims:

Sub F3 18 --38. A method of polishing a surface of a workpiece, the method comprising:

holding a workpiece with a top ring;

applying a first polishing pressure to a central portion of the workpiece;

applying a second polishing pressure to an outer circumferential portion of the workpiece, wherein the first polishing pressure is different than the second polishing pressure, and the first and second polishing pressures are independently adjustable; and

pressing a presser ring against a polishing surface.

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01 FC:103
02 FC:102

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